

Rotating Heater

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PLD

FEATURES:

- 1200°C Maximum temperature in O₂
- Virtually any substrate size available (chamber size determines substrate maximum size)
- Load-lock compatible
- 90° orientation for multiple port line-of-sight
- Substrate clamps
- Removable heating module
- Electronic temperature monitoring and programming
- UHV compatible
- Custom configurations available



NBM offer's a complete line of rotating heaters for use in a variety of deposition processes. The heaters are designed to withstand extreme operating environments that are typical of high-temperature deposition environments. Our design allows for easy integration with load-lock equipment for in-situ substrate transfer. The modular design of our heater also enables customizations to meet specific requirements not already met.

Rotating heater shown in deposition position with multi-target manipulator.



Customizations available:

- Variable substrate sizes
- Alternate substrate-normal orientation
- Automation package



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